

DOCKET NO: 283485US0PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

MASATOMO SUMIYA, ET AL. : EXAMINER: LEONG, NATHAN T.

SERIAL NO: 10/562,265 :

FILED: MAY 24, 2006 : GROUP ART UNIT: 1792

FOR: METHOD FOR GROWING THIN
NITRIDE FILM ONTO SUBSTRATE AND
THIN NITRIDE FILM DEVICE

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Official Action dated January 21, 2010, reconsideration is respectfully requested in the above-identified application in view of the following amendments and remarks:

Amendments to the Specification begin on page 2 of this response.

Amendments to the Claims begin on page 3 of this response.

Support for the Amendments begin on page 5 of this response.

Remarks begin on page 6 of this response.